


Sheet 1 of 1

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 05542-539001	Application No. 10/643,583
	Applicant Jeffrey Drue David			
	Filing Date August 18, 2003		Group Art Unit 3723	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
✓	AA	RE 35, 703	12/1997	Koch et al.			
	AB	4,005,359	01/1977	Smoot			
	AC	4,112,365	09/1978	Larson et al.			
	AD	4,303,885	12/1981	Davis et al.			
	AE	4,467,281	08/1984	Davis et al.			
	AF	4,556,845	12/1985	Strope et al.			
	AG	4,673,877	06/1987	Sakamoto et al.			
	AH	4,715,007	12/1987	Fujita et al.			
	AI	5,433,651	07/1995	Lustig			
	AJ	5,559,428	09/1996	Li et al.			
	AK	5,609,511	03/1997	Moriyama et al.			
	AL	5,738,574	04/1998	Tolles et al.			
	AM	5,838,447	11/1998	Hiyama et al.			
	AN	5,949,927	09/1999	Tang			
	AO	6,068,539	05/2000	Bajaj et al.			
	AP	6,159,073	12/2000	Wiswesser et al.			
	AQ	6,183,354	02/2001	Zuniga et al.			
	AR	6,280,289	08/2001	Wiswesser et al.			
	AS	6,296,548	10/2001	Wiswesser et al.			
	AT	6,433,541	08/2002	Lehman et al.			
	AU	6,558,229	05/2003	Kimura et al.			
	AV	6,707,540	03/2004	Lehman et al.			

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes. No.
Other Documents (include Author, Title, Date, and Place of Publication)							
Examiner Initial	Desig. ID	Document					

Examiner Signature 	Date Considered 7/21/05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Disclosure Form (PTO-1449)

Attorney's Docket No.: 008114-539001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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MAR 14 2005

Applicant : Jeffrey Drue David
Serial No. : 10/643,583
Filed : August 18, 2003
Title : PLATEN AND HEAD ROTATION RATES FOR MONITORING CHEMICAL
MECHANICAL POLISHING

Art Unit : 3723
Examiner : Maurina T. Rachuba

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Applicant admits the subject matter at page 7, lines 14-26 ("For a uniform polishing large number of subsequent rotations.") as prior art.

This statement is being filed after a request for continued examination and before the receipt of a first Office Action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 3/14/05

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I hereby certify that this correspondence is being transmitted by facsimile to the Patent and Trademark Office on the date indicated below.

Date of Transmission March 14, 2005Signature 

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